## Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

## Correspondence Address:

FROMMER LAWRENCE & HAUG LLP

745 FIFTH AVENUE

NEW YORK, NEW YORK 10151

TEL: (212) 588-0800 FAX: (212) 588-0500

Attorney Docket No.:

January 25. 450100-02952

ASSISTANT COMMISSIONER FOR PATENTS Box Patent Application Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Katsushi SATO, Kumiko SASAKI

entitled:

RESERVATION REGISTRATION APPARATUS, METHOD OF RESERVATION REGISTRATION AND PROGRAM STORAGE MEDIUM

| The following are enclosed:  X Specification (42 pages)  X 10 Sheet(s) of Drawings  X 18 Claim(s) (including 3 independent claim(s))  This application contains a multiple dependent claim |
|--|
| X Our check for \$\frac{\$710.00}{}\$, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:  |
| Basic Fee, \$710.00 (\$355.00)   |
| <pre>X Oath or Declaration and Power of Attorney     X New</pre>   |
| $\underline{X}$ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:  |
| Application No. Filed In   |

2000-024801

28 January 2000

Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP Attorneys for Applicants

William S. Frommer

Reg. No. 25,506

1-26-0



"Express Mail" mailing label number EL742664711US

Date of Deposit \_\_\_\_\_\_ January 25, 2001

I hereby certify that this paper or fee, and a patent application and accompanying papers, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

## FROMMER LAWRENCE & HAUG LLP

745 FIFTH AVENUE NEW YORK, NEW YORK 10151

WILLIAM S. FROMMER WILLIAM F. LAWRENCE

EDGAR H. HAUG MATTHEW K. RYAN BARRY S. WHITE

THOMAS J. KOWALSKI

JOHN R. LANE
DENNIS M. SMID \*

DANIEL G. BROWN
BARBARA Z. MORRISSEY

STEVEN M. AMUNDSON

Märilyn Matthes Brogan James K. Stronski

Charles J. Raubicheck Grace L. Pan\*

GORDON KESSLER MARK W. RUSSELL\* JEFFREY A. HOVDEN

A. Thomas S. Safford Jerome Rosenstock

RAYMOND R. WITTEKIND, Ph.D. SUSAN K. LEHNHARDT, Ph.D.

RICHARD E. PARKE Of Counsel

BRUNO POLITO

Joe H. Shallenburger Christian M. Smolizza Glenn F. Savit

RÖBERT E. COLLETTI
DEXTER T. CHANG
PETER J. WAIBEL

Endsey A. Möhle Bena P. Levy

DARREN M. SIMON YUFENG LIU, Ph.D.

JOHN G. TAYLOR

\*Admitted to a Bar
other than New York

January 25, 2001

Assistant Commissioner for Patents

Washington, D.C. 20231

Re: U.S. Patent Application

Applicants: Katsushi SATO, Kumiko SASAKI

Our Ref.: 450100-02952

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

William S. Frommer, Esq. FROMMER LAWRENCE & HAUG LLP 745 Fifth Avenue New York, New York 10151

Respectfully,

William S. Frommer Reg. No. 25,506

Attorney for Applicants

Enclosures